

172/172



Attorney Docket # 5367-47RCE

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of  
Stefan BADER et al.  
Serial No.: 10/696,882  
Filed: October 30, 2003  
For: Method for Depositing a Material on a Substrate  
Wafer

Examiner: RAO, G. Nagesh  
Group Art: 1722

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 29, 2007  
(Date of Deposit)

Thomas Langer  
Name of applicant, assignee or Registered Representative

*Thomas Langer*  
Signature

May 29, 2007  
Date of Signature

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PETITION

Applicant hereby petition(s) for a 1-month extension of the original shortened statutory response period set in the Office Action of January 29, 2007. The Commissioner is hereby authorized to charge the amount of \$120.00 in payment of the government fee for a 1-month extension of time to our Patent and Trademark Office Deposit Account No. 03-2412.

AMENDMENT

SIR:

Responsive to the Office Action dated January 29, 2007, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

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